## **DECLARATION**

As a below named inventor, I hereby declare that:

My residence, post office address and citizenship are as stated below next to my name,

I believe I am the original, first and sole inventor (if only one name is listed below) or an original, first and joint inventor (if plural names are listed below) of the subject matter which is claimed and for which a patent is sought on the invention entitled:

## Vacuum Processing for Fabrication of Superconducting Thin Films Fabricated by Metal-Organic Processing

the specification of which (I authorize Choate, Hall & Schoices, and fill in the blanks, if applicable):	tewart to check one of the following, three			
is attached hereto				
X was filed on July 13, 2002 as Application & Stewart to fill in this information) and an	Serial No. 10/194,56 (I authorize Choate, Hall nended on (if applicable).			
was filed as PCT international application I on and was amend on (if applicable)	No, led under PCT Article 19			
I hereby state that I have reviewed and understood the contents of the above-identified specification, including the claims, as amended by any amendment referred to above.				
I acknowledged the duty to disclose information which is material to the examination of this application in accordance with Title 37, Code of Federal Regulations, §1.56.				
I hereby claim foreign priority benefits under Title 35, United States Code, §119 of any foreign application(s) for patent or inventor's certificate listed below and have also identified below any foreign application for patent or inventor's certificate having a filing date before that of the application on which priority is claimed:				
Prior Foreign Application(s): Pri	ority Claimed			

(Country)

(Country)

(Number)

(Number)

(Day/Month/Year/Filed)

(Day/Month/Year/Filed)

Yes No

Yes No

I hereby claim the benefit under Title 35, United States Code, §120 of any United States application(s) or PCT international application(s) designating the United States of America listed below and, insofar as the subject matter of each of the claims of this application is not disclosed in the prior United States application in the manner provided by the first paragraph of Title 35, United States Code, §112, I acknowledge the duty to disclose material information as defined in Title 37, Code of Federal Regulations, §1.56 which became available between the filing date of the prior application and the national or PCT international filing date of this application:

And the second second		
(Application Serial No.)	(filing date)	(status-patented, pending, abandoned)
PCT Applications designation	g the United States:	
(PCT Appl. No.)	(filing date)	(status-patented, pending, abandoned)
provisional application(s) lis application is not disclosed in paragraph of Title 35, United	ted below and, insofar in the prior United Stat I States Code, §112, I	nited States Code, §119(e) of any United States as the subject matter of each of the claims of this es application in the manner provided by the first acknowledge the duty to disclose information which ode of Federal Regulations, §1.56 which became

Provisional Application(s):

60/305,407	July 13, 2001	Abandoned
(Application Serial No.)	(filing date)	(status-patented, pending, abandoned)

available between the filing date of the prior application and the national filing date of this application.

I hereby declare that all statements made herein of my own knowledge are true and that all statements made on information and belief are believed to be true; and further that these statements were made with the knowledge that willful false statements and the like so made are punishable by fine or imprisonment, or both, under Section 1001 of Title 18 of the United State Code and that such willful false statements may jeopardize the validity of the application or any patents issued thereon.

1)	Full name of first inventor: <u>Igor Seleznev</u>		
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2)	Full name of second inventor: Michael J. Cima	·	
	Inventor's signature:	Date:	
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2)	Full name of second inventor, Michael J. Gima	<del>_</del>	
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